

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

For request for continued examination based on:

Applicants: Fang-An Shu. ) Confirmation No. 5863  
                              )  
Appl. No.: 10/711,864     ) Examiner: NGUYEN, THANH T  
                              )  
Filed: 10/11/2004       ) Group Art Unit: 2813  
                              )  
For: METHOD OF FABRICATING POLY- ) TKHR Ref. 251610-1040  
CRYSTAL ITO FILM AND        ) Tsai, Lee & Chen Ref. NP-4747-US  
POLYCRYSTALITO ELECTRODE     )

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The FINAL Office Action mailed March 1, 2006 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.

**Amendments to the claims begin on page 2 of this paper.**

**Remarks begin on page 5 of this paper.**